

Title (en)

ATOMIC LAYER DEPOSITION SYSTEM AND METHOD

Title (de)

VORRICHTUNG UND VERFAHREN ZUR ABSCHIEDUNG VON ATOMAREN SCHICHTEN

Title (fr)

SYSTEME ET PROCEDE DE DEPOT EN COUCHES ATOMIQUES

Publication

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Application

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- US 97086701 A 20011003
- US 99949901 A 20011024
- US 99953201 A 20011024
- US 99963601 A 20011024
- US 38201 A 20011024
- US 82501 A 20011024
- US 448801 A 20011024
- US 2759201 A 20011219

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